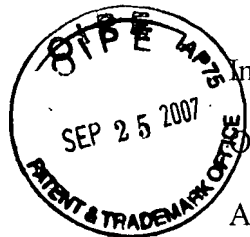


03500.103394.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of: )  
: )  
OSAMU KANOME, et al. )  
: Group Art Unit: 1744  
Application No.: 10/582,099 )  
: )  
Intl. Filing Date: December 13, 2004 )  
: )  
371(c) Date: March 19, 2007 )  
: )  
For: SUBSTRATE FOR CELL )  
CULTURE, PRODUCING )  
METHOD THEREOF AND )  
SCREENING METHOD FOR )  
CELL CULTURE CONDITIONS )  
UTILIZING THE SAME : September 24, 2007

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Applicants have received an official Filing Receipt in the above-identified application in which the name of the fifth inventor is incorrect and the residences for four of the inventors are listed incorrectly.

The name for the fifth-named inventor should read:

--Ryoichi Matsuda--.

The residence for the first-named inventor should read:

--Yokohama-shi, JAPAN--.

The residence for the second-named inventor should read:

--Chofu-shi, JAPAN--.

The residence for the third-named inventor should read:

--Yokohama-shi, JAPAN--.

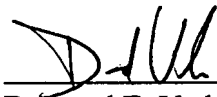
The residence for the fourth-named inventor should read:

--Nishitokyo-shi, JAPAN--.

The requested corrections are indicated on the attached marked-up copy of the Filing Receipt. Issuance of a corrected Filing Receipt is accordingly respectfully requested.

Applicants' undersigned attorney may be reached in our Costa Mesa, California office at (714) 540-8700. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

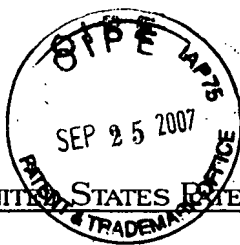


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Damond E. Vadnais  
Attorney for Applicants  
Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-2200  
Facsimile: (212) 218-2200

FCBS\_WS 1549375v1



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
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 Alexandria, Virginia 22313-1450  
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APPL NO.	FILING OR 371(c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	TOT CLMS	IND CLMS
10/582,099	03/19/2007	1744	1280	03500.103394.	25	1

5514

FITZPATRICK CELLA HARPER & SCINTO  
 30 ROCKEFELLER PLAZA  
 NEW YORK, NY 10112

DEN

CONFIRMATION NO. 1165

## FILING RECEIPT



\*OC000000025138115\*

Date Mailed: 08/02/2007

Receipt is acknowledged of this nonprovisional patent application. The application will be taken up for examination in due course. Applicant will be notified as to the results of the examination. Any correspondence concerning the application must include the following identification information: the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).**

## Applicant(s)

Osamu Kanome, ~~Kanagawa-ken, JAPAN;~~ Yokohama-shi, JAPAN;  
 Kohei Watanabe, ~~Tokyo, JAPAN;~~ Chofu-shi, JAPAN;  
 Takeshi Miyazaki, ~~Kanagawa-ken, JAPAN;~~ Yokohama-shi, JAPAN;  
 Tomoyo Fujiyama, ~~Tokyo, JAPAN;~~ Nishitokyo-shi, JAPAN;  
~~Byeichi Matsuda, Tokyo, JAPAN;~~  
 Ryoichi

## Assignment For Published Patent Application

Canon Kabushiki Kaisha, Tokyo, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 5514.

## Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/18962 12/13/2004

## Foreign Applications

JAPAN 2003-418560 12/16/2003

AUG - 7 2007

If Required, Foreign Filing License Granted: 08/01/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/582,099**

Projected Publication Date: 11/08/2007

**Non-Publication Request:** No

**Early Publication Request:** No

**Title**

Substrate for Cell Culture, Producing Method Thereof and Screening Method for Cell Culture Conditions Utilizing the Same

**Preliminary Class**

435

## **PROTECTING YOUR INVENTION OUTSIDE THE UNITED STATES**

Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filing of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process **simplifies** the filing of patent applications on the same invention in member countries, but **does not result** in a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

Almost every country has its own patent law, and a person desiring a patent in a particular country must make an application for patent in that country in accordance with its particular laws. Since the laws of many countries differ in various respects from the patent law of the United States, applicants are advised to seek guidance from specific foreign countries to ensure that patent rights are not lost prematurely.

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Applicants may wish to consult the USPTO booklet, "General Information Concerning Patents" (specifically, the section entitled "Treaties and Foreign Patents") for more information on timeframes and deadlines for filing foreign patent applications. The guide is available either by contacting the USPTO Contact Center at 800-786-9199, or it can be viewed on the USPTO website at <http://www.uspto.gov/web/offices/pac/doc/general/index.html>.

For information on preventing theft of your intellectual property (patents, trademarks and copyrights), you may wish to consult the U.S. Government website, <http://www.stopfakes.gov>. Part of a Department of Commerce initiative, this website includes self-help "toolkits" giving innovators guidance on how to protect intellectual property in specific countries such as China, Korea and Mexico. For questions regarding patent enforcement issues, applicants may call the U.S. Government hotline at 1-866-999-HALT (1-866-999-4158).

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Title 37, Code of Federal Regulations, 5.11 & 5.15**

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